



## UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE  
 United States Patent and Trademark Office  
 Address: COMMISSIONER FOR PATENTS  
 P.O. Box 1450  
 Alexandria, Virginia 22313-1450  
 www.uspto.gov



Bib Data Sheet

CONFIRMATION NO. 9438

<b>SERIAL NUMBER</b> 10/535,741	<b>FILING OR 371(c) DATE</b> 05/18/2005 <b>RULE</b>	<b>CLASS</b> 438	<b>GROUP ART UNIT</b> 2812	<b>ATTORNEY DOCKET NO.</b> 4878/PCT
<b>APPLICANTS</b> Seiji Nakahata, Hyogo, JAPAN; Ryu Hirota, Hyogo, JAPAN; Keiji Ishibashi, Hyogo, JAPAN; Takatomo Sasaki, Suita-shi, JAPAN; Yusuke Mori, Katano-shi, JAPAN;				
<b>** CONTINUING DATA *****</b> This application is a 371 of PCT/JP04/08090 06/03/2004				
<b>** FOREIGN APPLICATIONS *****</b> JAPAN 2003-170584 06/16/2003				
Foreign Priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance Verified and Acknowledged _____ Examiner's Signature _____ Initials _____		<b>STATE OR COUNTRY</b> JAPAN	<b>SHEETS DRAWING</b>	<b>TOTAL CLAIMS</b> 12
<b>INDEPENDENT CLAIMS</b> 3				
<b>ADDRESS</b> 21553				
<b>TITLE</b> Mehtod for processing nitride semiconductor crystal surface and nitride semiconductor crystal obtained by such method				
<b>FILING FEE RECEIVED</b> 900	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit	